

CF₄ Gas Test for GEM-TPC

Sokendai(KEK)
Ryo YONAMINE

~OUTLINE~

1. PURPOSE
2. THIS WORK
3. RESULTS
4. SUMMARY
5. PLANS

Collaboration with
KEK, TUAT, KogakuinU
KinkiU, SagaU
MPI, Saclay, TsinghuaU

I.PURPOSE

WHY NEED GAS TEST ?

The chamber gas plays important roles in order to measure the position of tracks.

The gas decide three parameters.

1. velocity of drifting electrons (V_{drift})
2. diffusion constant of drifting electrons (C_D)
3. the effective number of seed electrons (N_{eff})

PURPOSE OF OUR STUDY

According to GARFIELD,
CF₄ gas mixtures are likely to give low C_D.
But, ...

problem

CF₄ gas mixtures are not yet fully studied as GEM-TPC gas.

Our task is to confirm
whether these gases can become GEM-TPC gas.

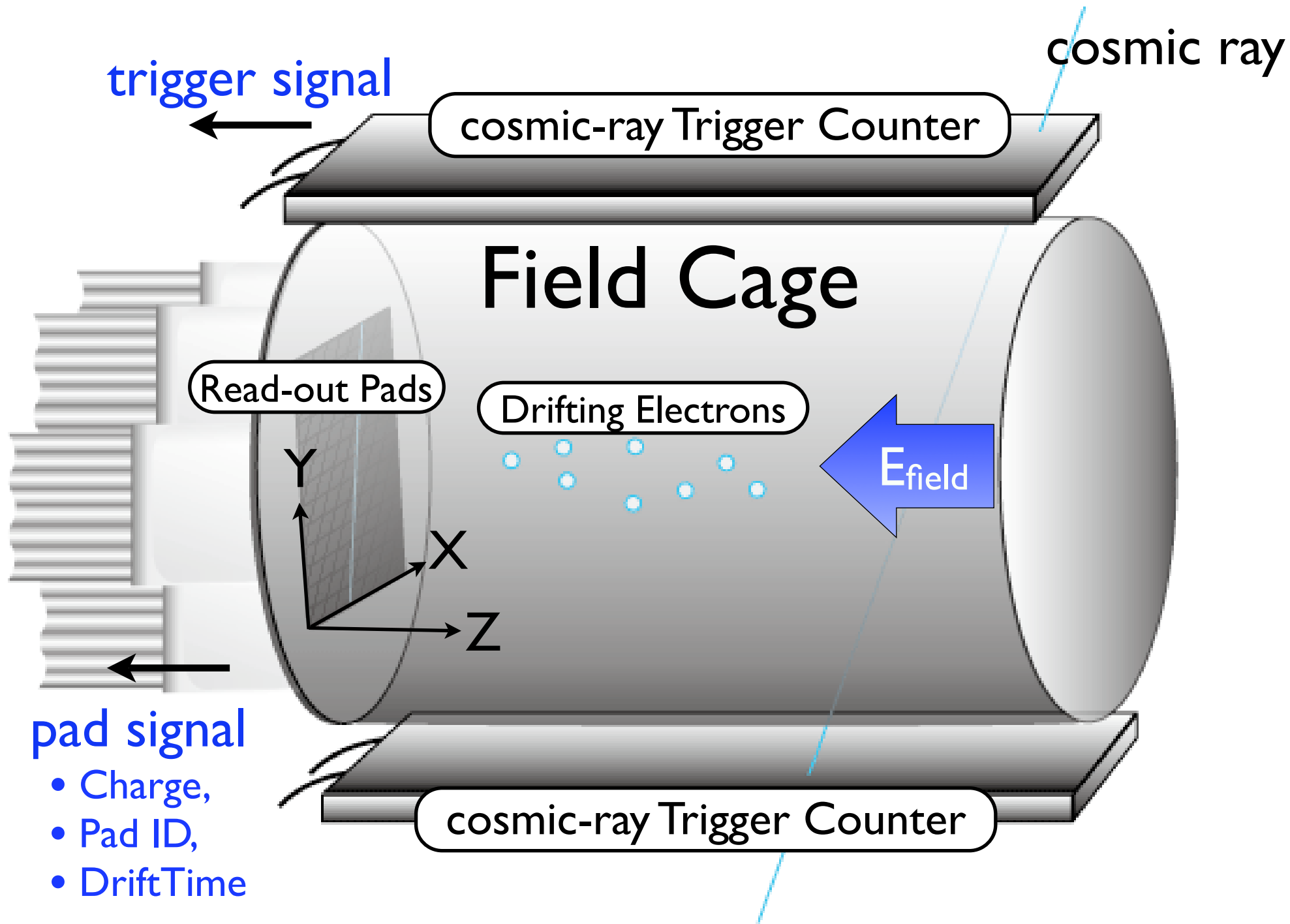
2.THIS WORK

THIS WORK

~cosmic ray test~

We tested **Ar-CF₄-isoC₄H₁₀(94:3:3)** with GEM-TPC
as a first step, (Source was cosmic ray)
and estimated **V_{drift}**, **C_D**(transverse) and **N_{eff}**.

And we compared our measurement with GARFIELD
in V_{drift} and C_D.



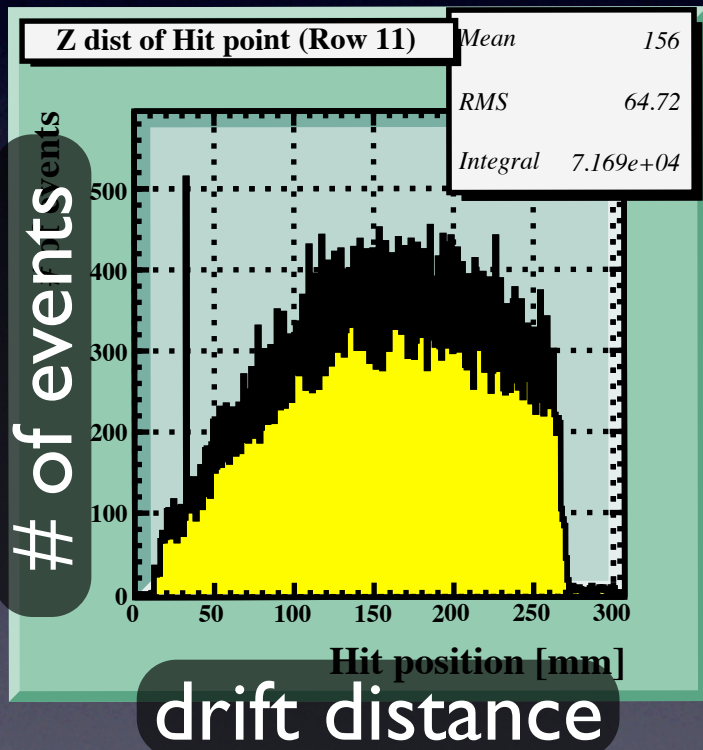
PROBLEMS IN DATA ANALYSIS

This is one of the histograms which shows Z-distribution of “seed electrons”.

We estimated V_{drift} from this.
(Drift distance should be TPC length.)

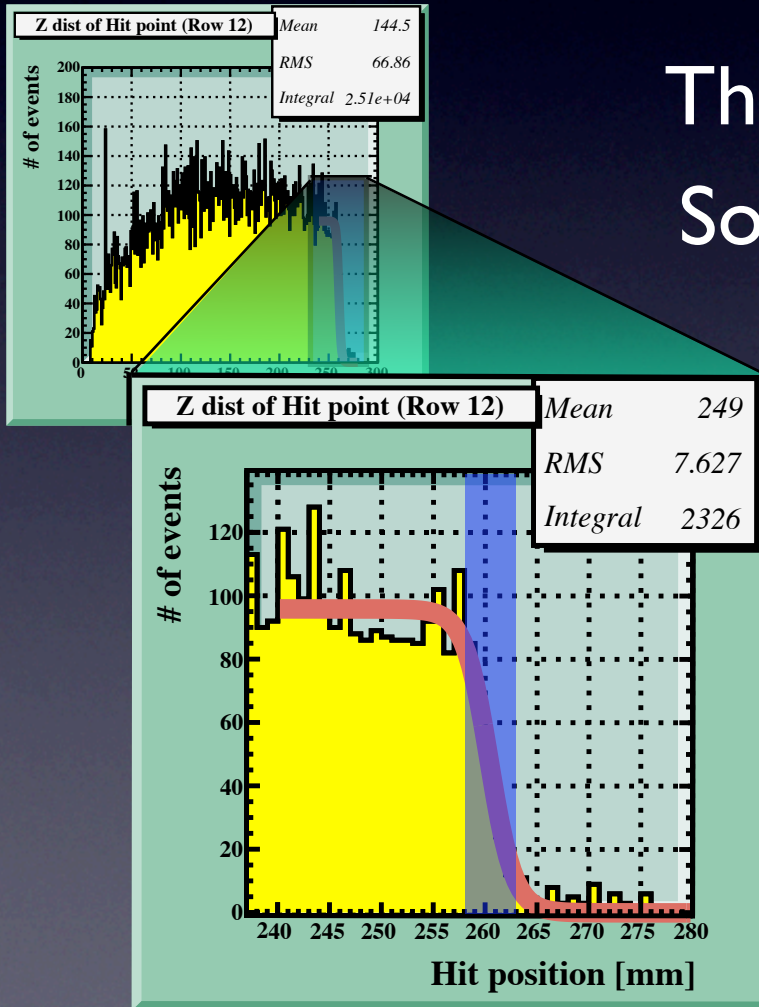
Here, there are two problems.

1. What's the gap at left side ?
2. What's the value of the end point ?
(right side)



OUR ACTION FOR THE PROBLEMS I

Where's the right side end ?



The right edge is slightly-tilted.

So we define the end point as follows.

1. fit the edge as $y = \frac{a_0}{\exp\left[\frac{x-a_1}{a_2}\right]}$
(Red Line)

2. let the end point = $a_1 \pm 2a_2$
(Blue Region)

OUR ACTION FOR THE PROBLEMS 2

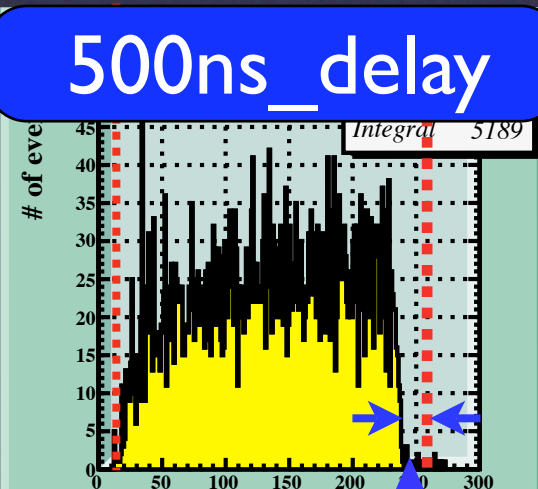
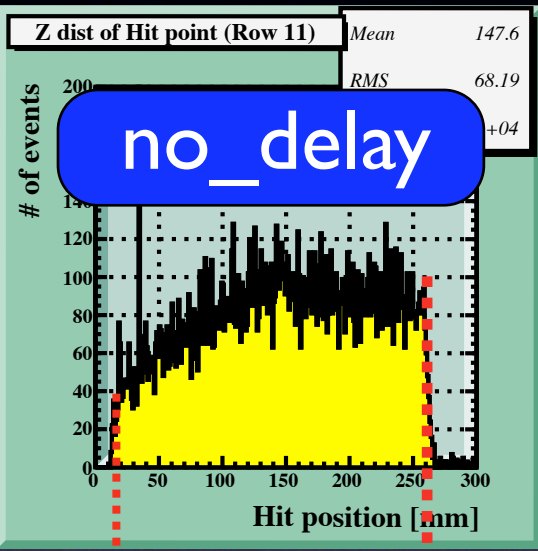
What's the gap at left side ?

We tested with delayed trigger gate.
Histograms were expected to move to the left because of the trigger delay.

Result (left figure)

- Right edge moved reasonably.
- No change was seen with Left edge.

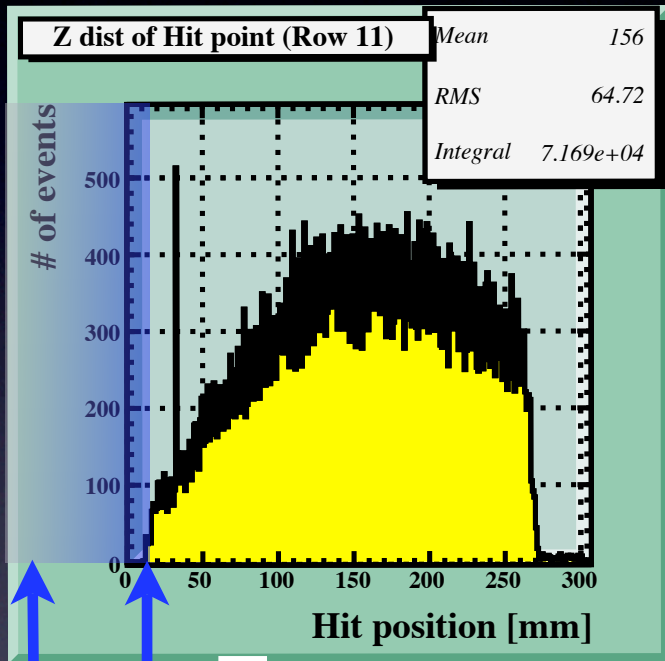
From this result, we take the left gap as something like “invisible region”.



correspond to 500ns

NEW PROBLEM

Where is T_0 ?



not T_0

“invisible region”

~ T_0 calibration by P10 ~

We calibrated T_0 by using P10 gas.

	our measurement	Garfield
C_D	113 ± 4.8	116.7
V_{drift}	?	5.37

ASSUMPTION

P10 gas give also some consistency in V_{drift} .

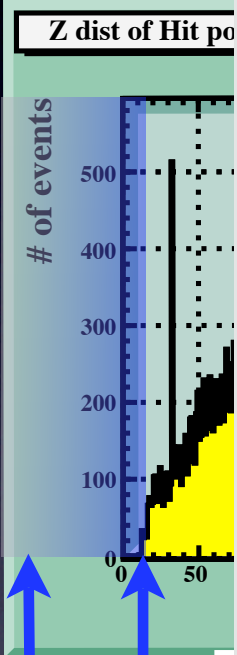
$$V_{\text{drift}}(\text{P10}@E=108.5[\text{V/cm}])=5.37 \pm 0.30$$

We estimate T_0 by analysis for P10.

NEW



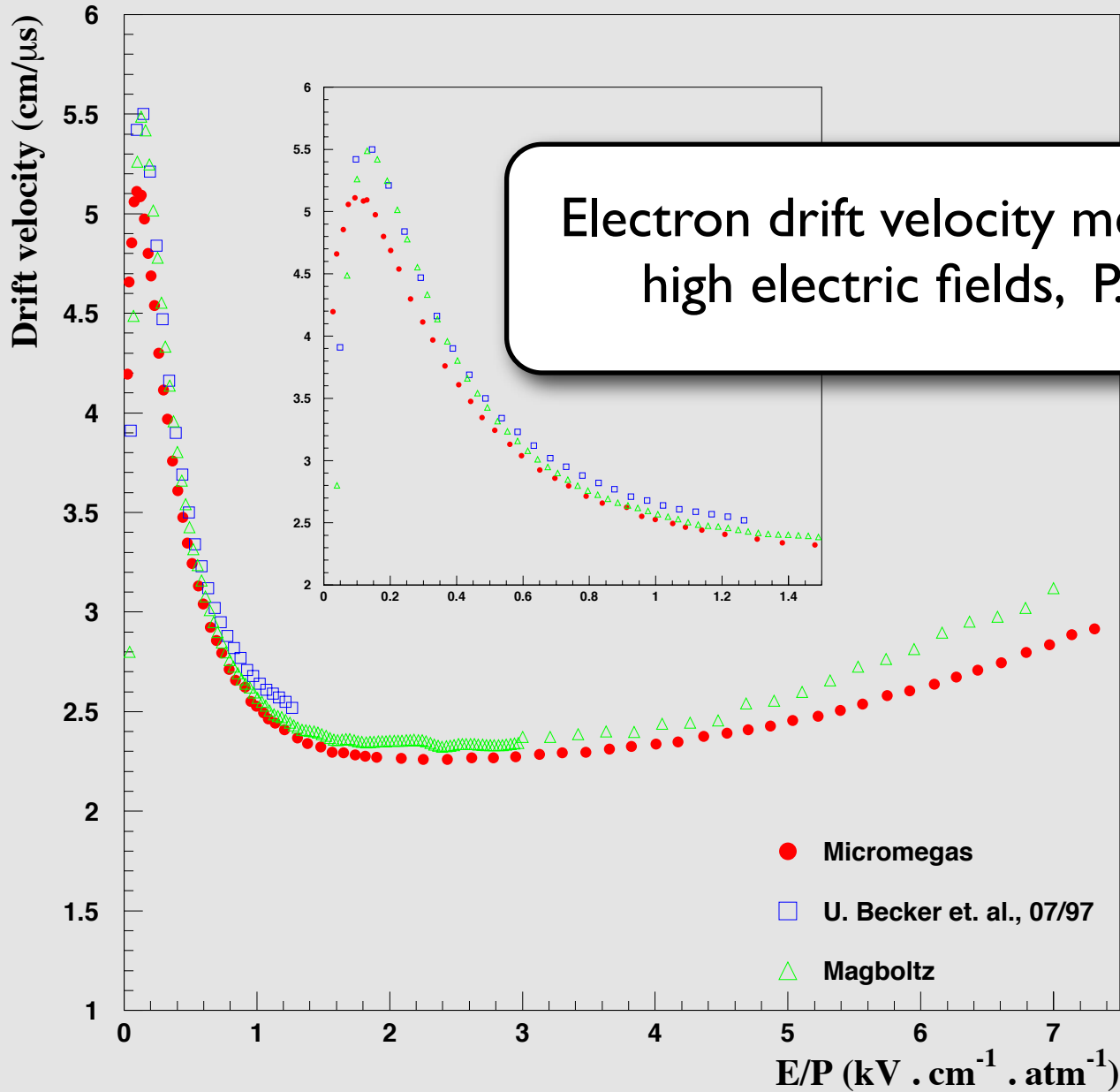
Who



not

“invisible”

P10



Electron drift velocity measurements at high electric fields, P.Colas et al.

7

ency
n V_{drift} .
0.30

P10.

Fig. 4. Calibration in P10.

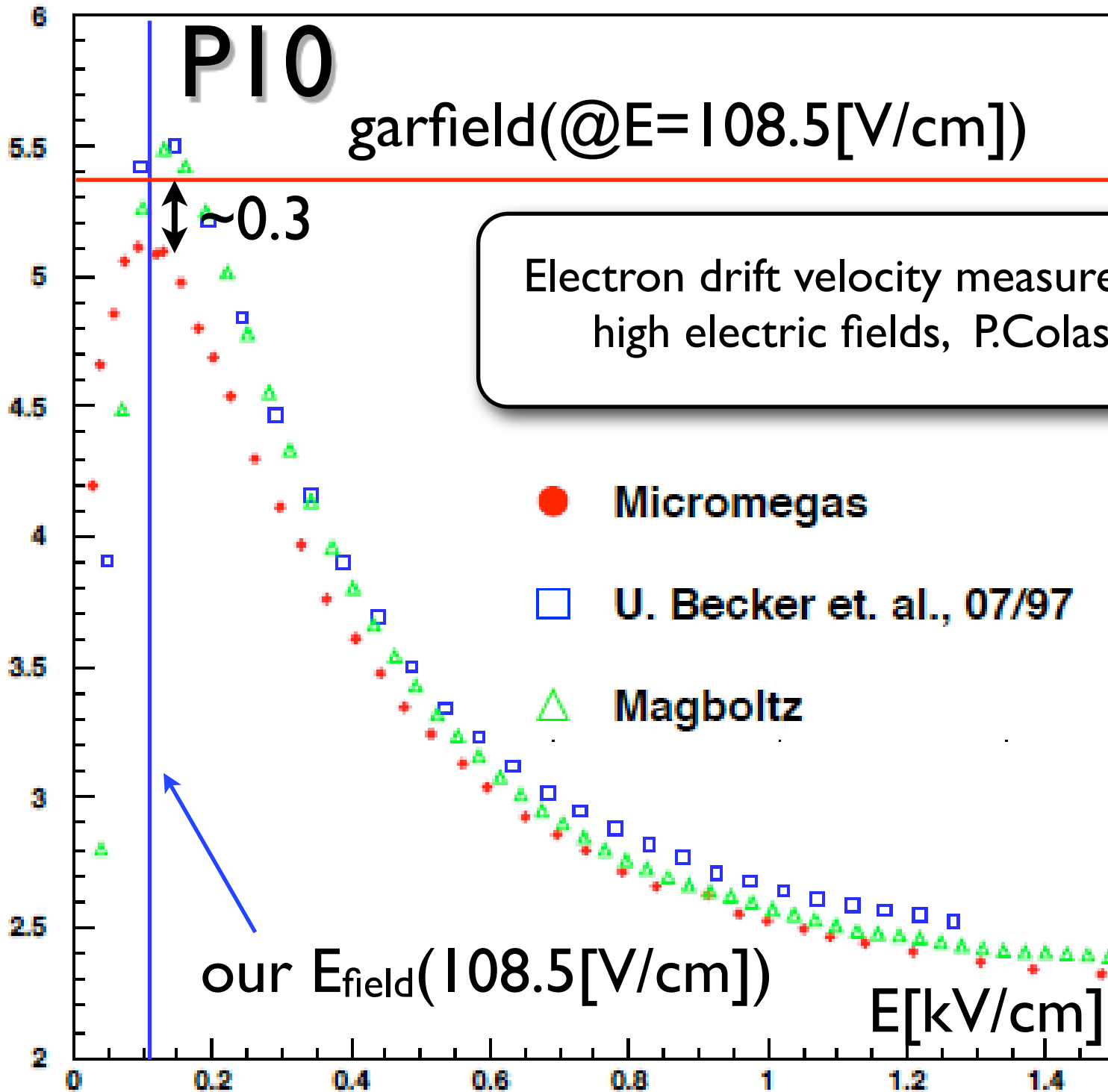
NEW



W

Drift Velocity [cm/ μ s]

“invisi



ncy

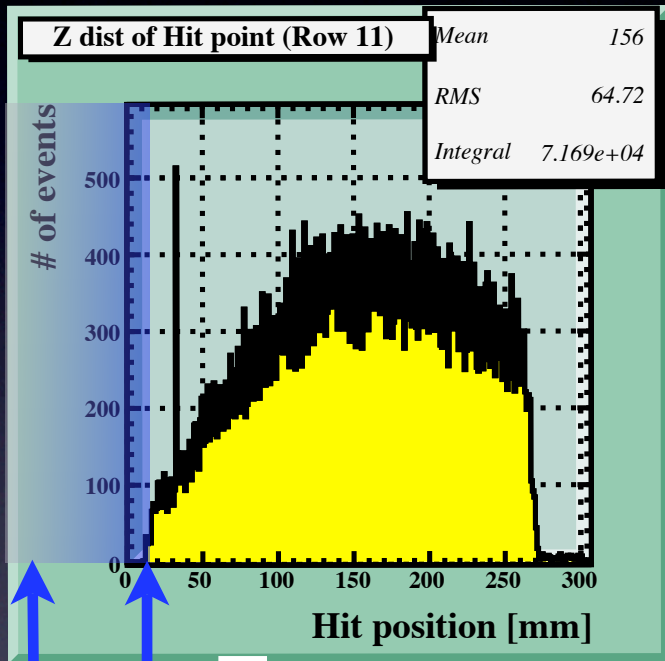
v_{drift}

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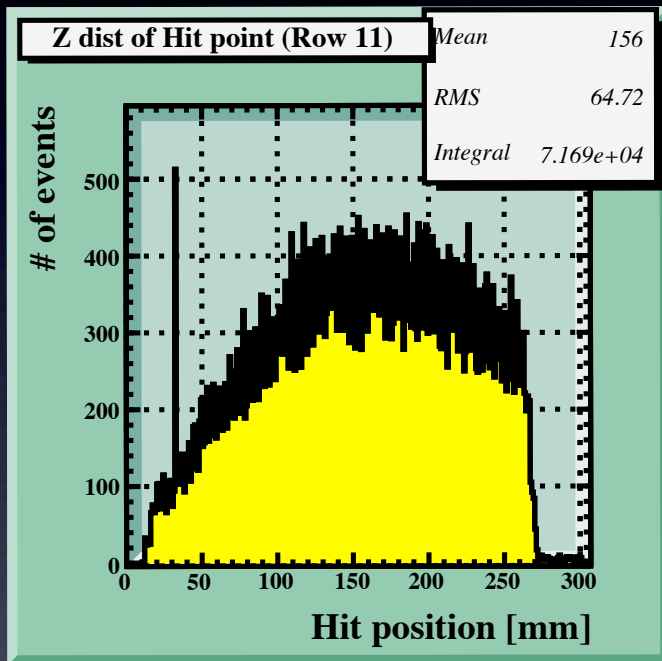
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SUMMARY OF OUR ACTION

FOR THE PROBLEMS ~analysis procedure~



1. Obtain the value of end point (Z_{end}) by fitting the right edge.
2. Obtain Z-offset by using T_0 from P10 test.
3. Obtain drift-length (L_{measure}) from 1, 2.

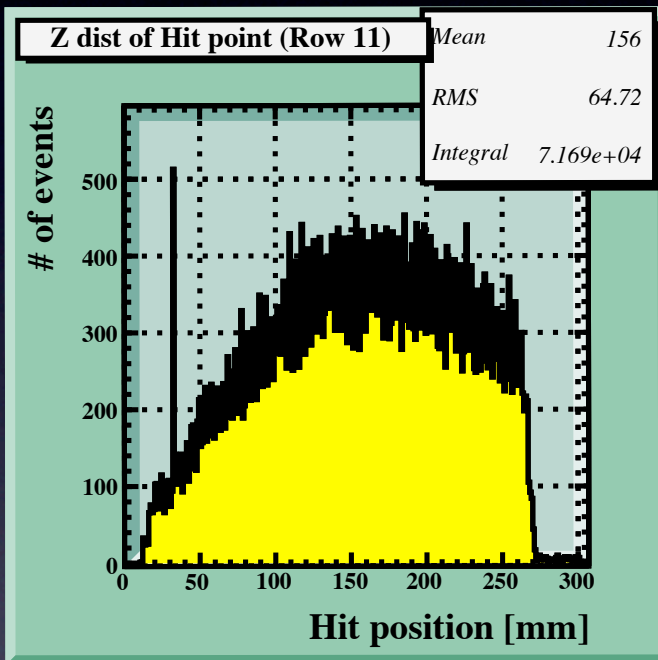
4. Calibrate V_{drift} to make consistency in L_{measure} and L_{true} .
($L_{\text{true}} = 254\text{mm}$)

As a result, V_{drift} includes error originated from

Z_{end} and $V_{\text{drift}}(\text{P10})$.

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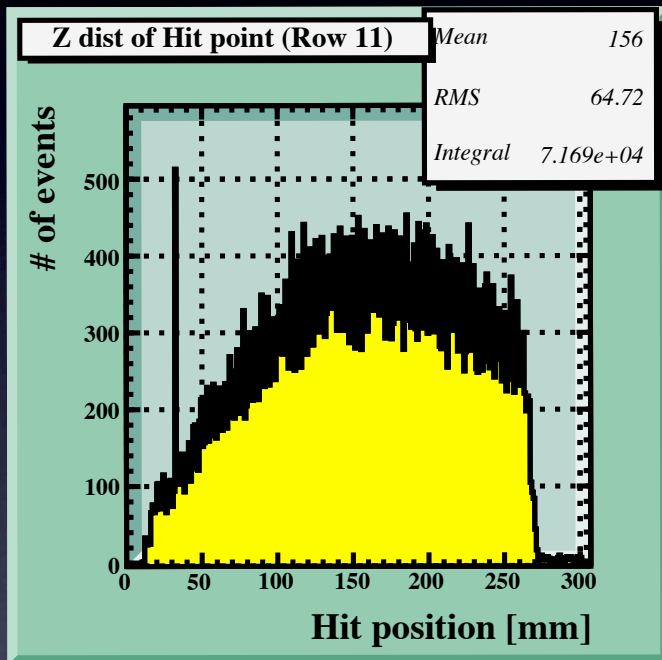
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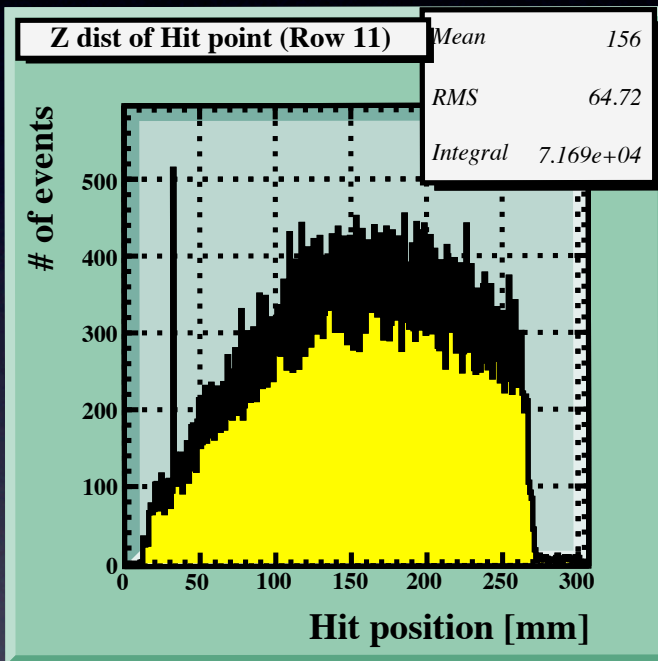
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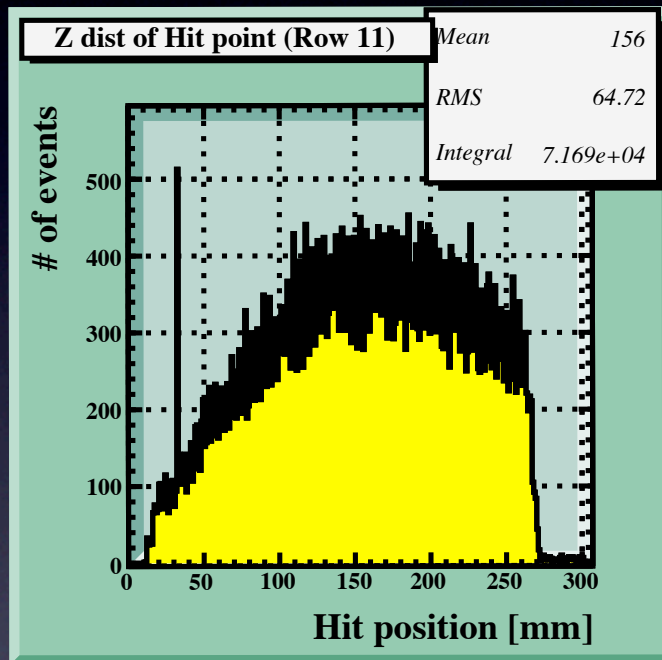
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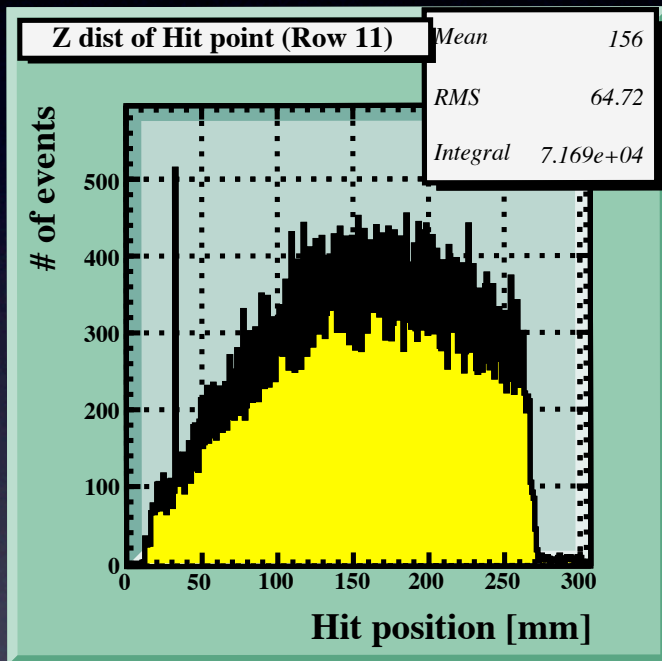
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3.RESULTS

Ar-CF4-iso C4H10(94:3:3) TEST

We tested the following condition.

$$E=80, 100, 120, 135, 150[\text{V/cm}] \quad B=1[\text{T}]$$

RESULTS

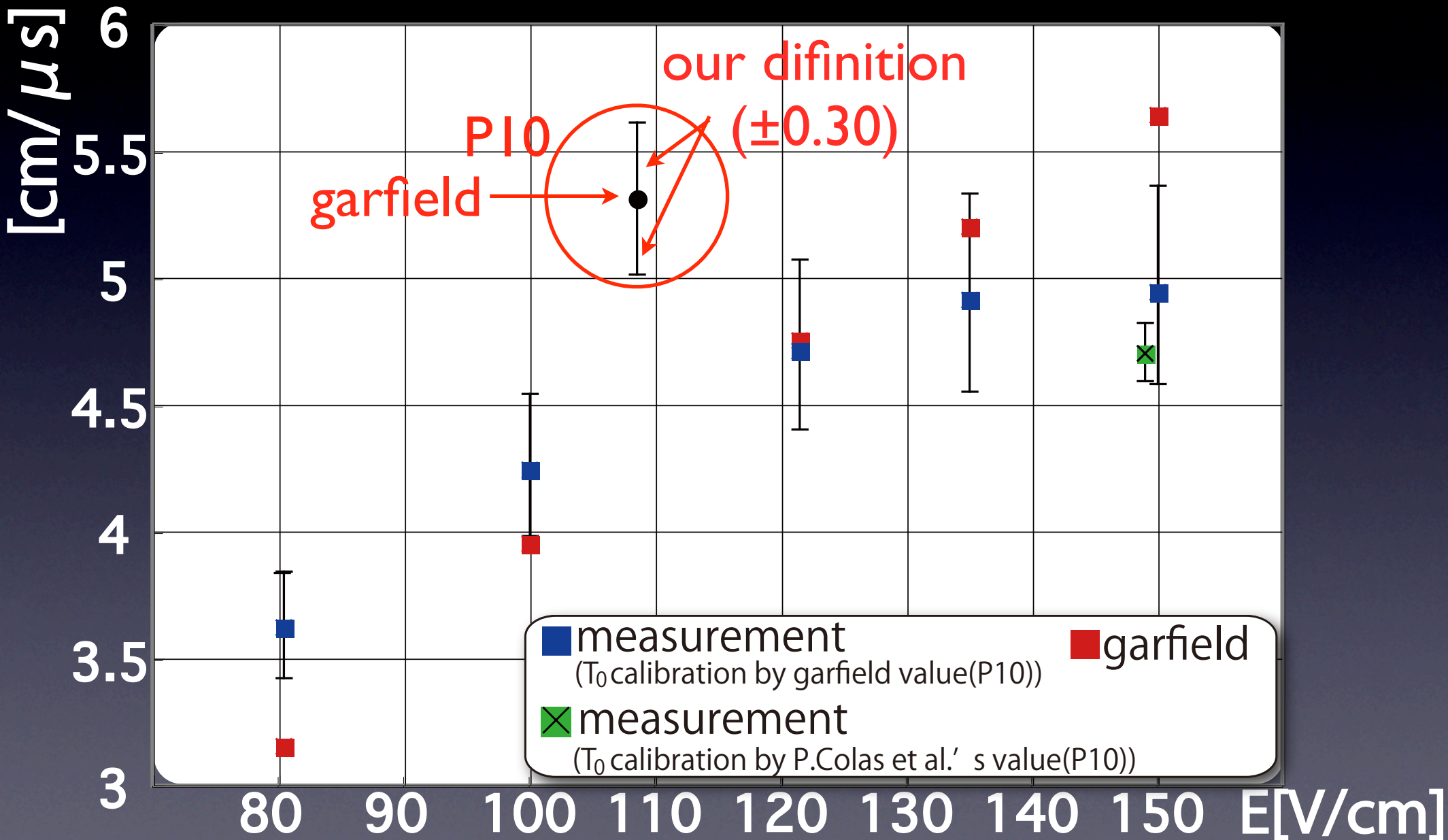
$E[\text{V/cm}]$	N_{eff}	# of tracks
80	23 ± 6	$\sim 21,000$
100	21 ± 8	$\sim 18,000$
120	25 ± 9	$\sim 17,000$
135	24 ± 9	$\sim 16,000$
150	21 ± 2	$\sim 64,000$

→ No Problem with Electron Attachment

COMPARISON TO GARFIELD

~DriftVelocity~

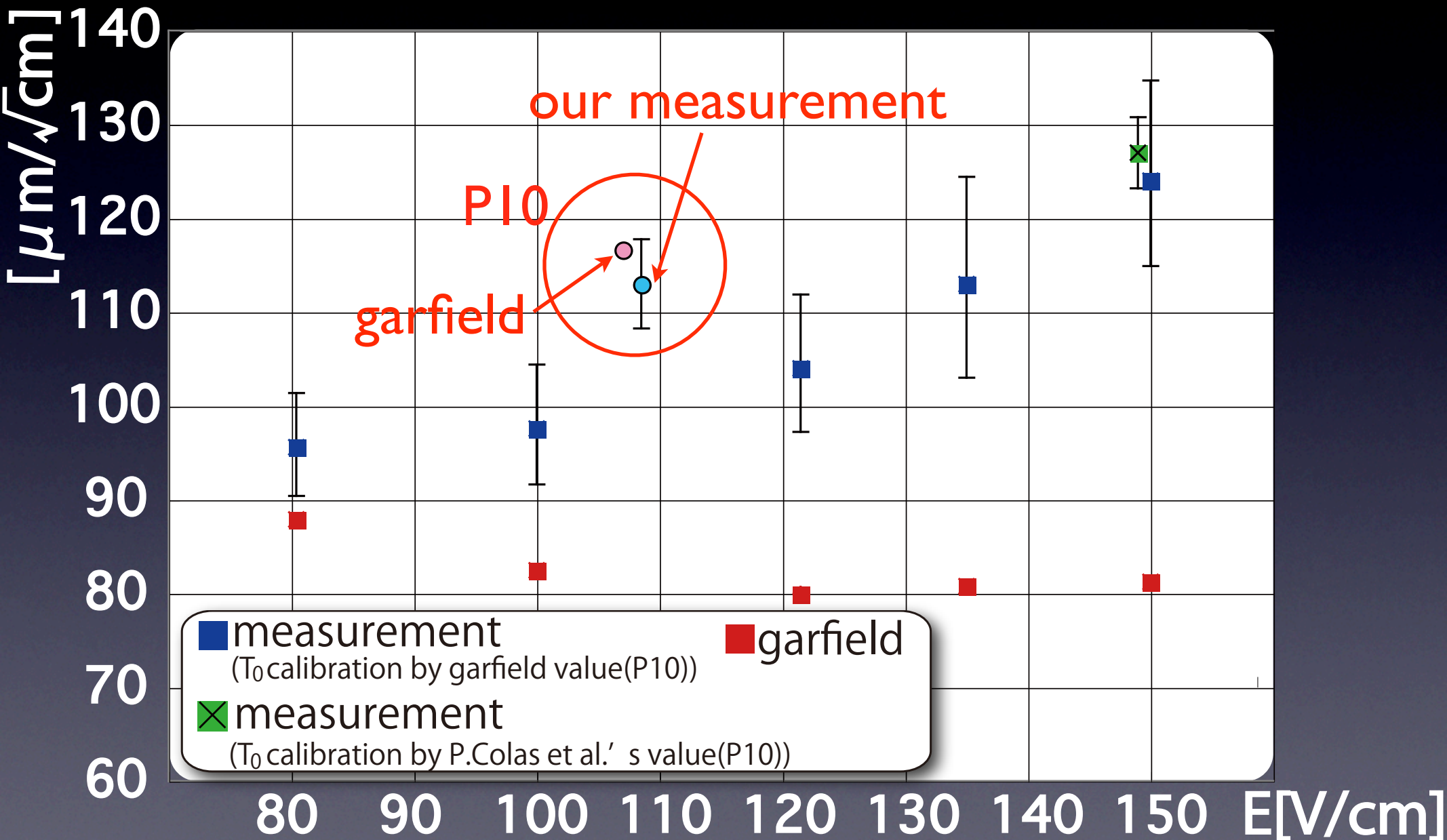
Ar-CF₄-isoC₄H₁₀(94:3:3)



COMPARISON TO GARFIELD

~DiffusionConstant~

Ar-CF₄-isoC₄H₁₀(94:3:3)



4.SUMMARY

SUMMARY

We tested Ar-CF₄-isoC₄H₁₀(94:3:3) as GEM-TPC gas,
(cosmic-ray test, E=80,100,120,135,150[V/cm], B=1[T])
and
compared with GARFIELD.

CONCLUSIONS

We can confirm Ar-CF₄-isoC₄H₁₀ (94:3:3) work
as GEM-TPC gas @E=80~150[V/cm]
(N_{eff} seems to be O.K.)

Discrepancy can be seen between our results and garfield.
(especially at high electric field)

5.PLANS

PLANS

Bito-san(TUAT) is going to
measure V_{drift} in our condition independently.
So, we'd like to compare the results to ours.

- Test with other E,B field , same gas
E=50, 180,...[V/cm]
B=0[T]

- Test with other gases

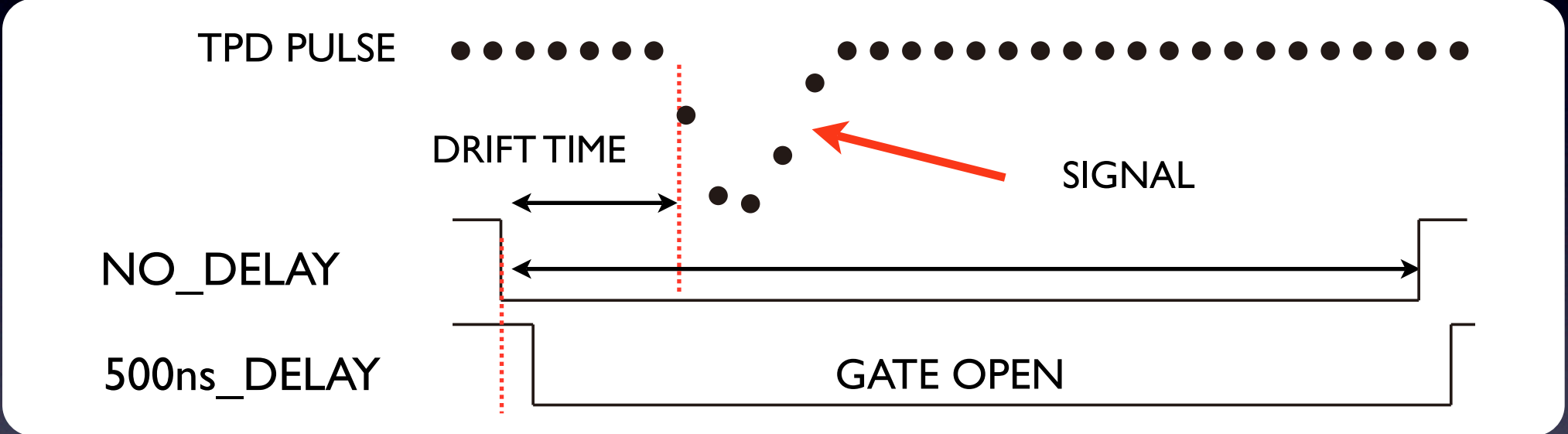
Ar-CF₄-isoC₄H₁₀(95:3:2)

Ar-CF₄-isoC₄H₁₀(96:3:1)

⋮



Study about advantage
of
CF₄ gas mixtures



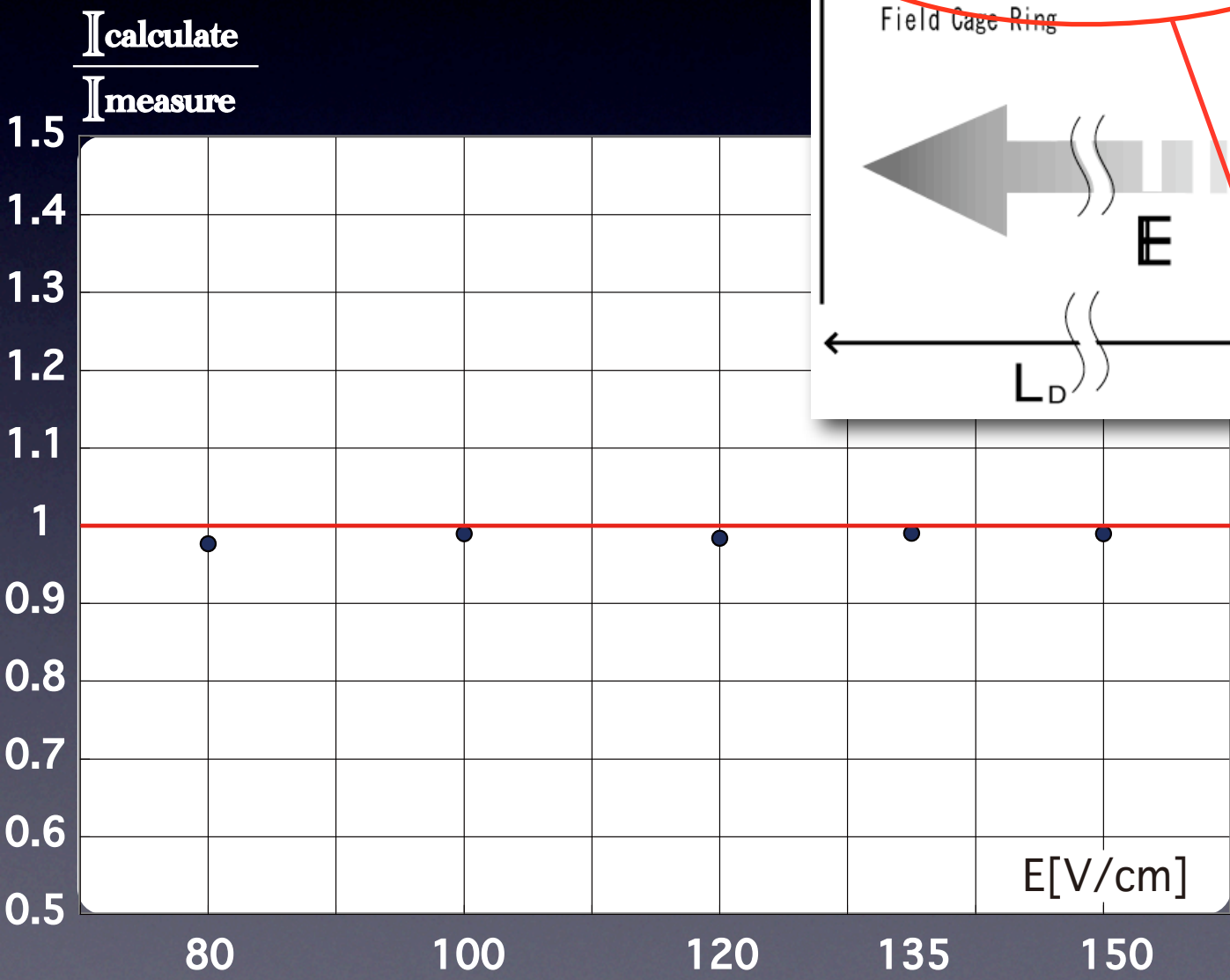
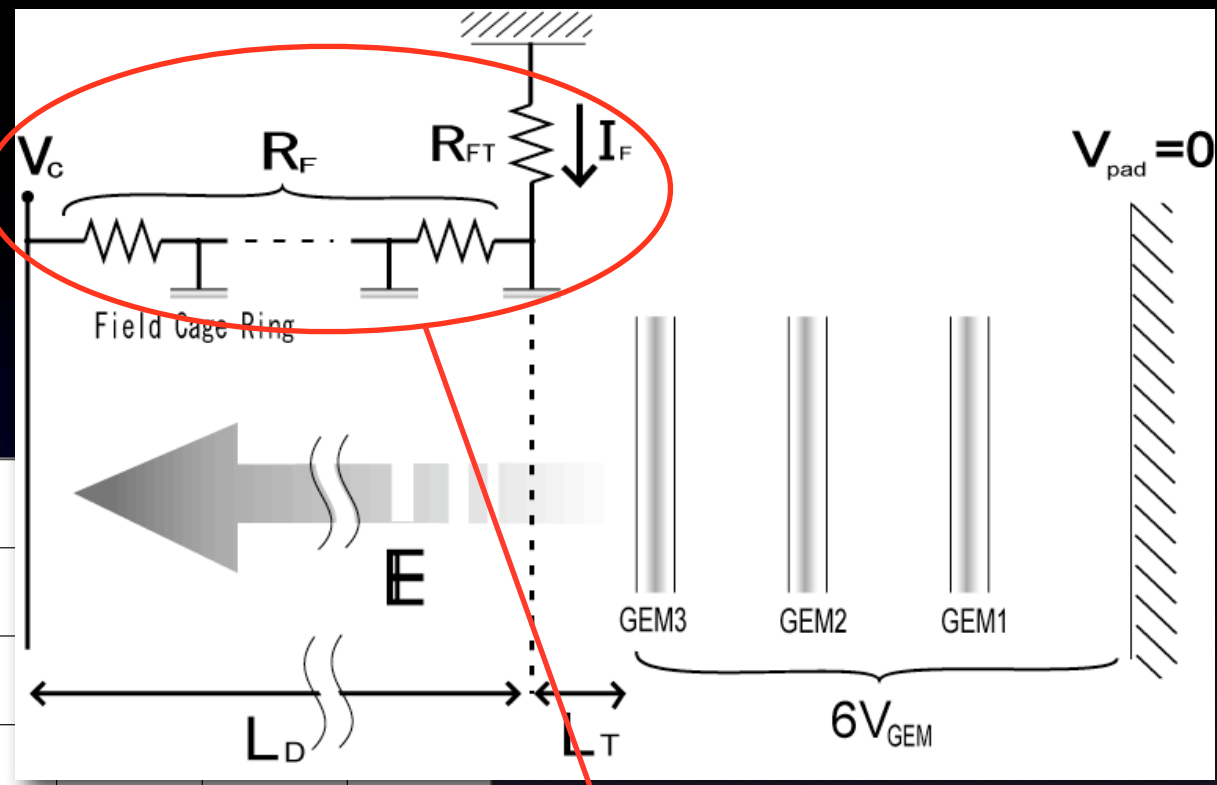
CHECK H.V. SUPPLIER

Chamber Sketch

DEFINITION

$I_{measure}$: indicated current value

$I_{caluculate}$: caluculated from voltage



$$I_{calculate} = \frac{V_c}{(R_F + R_{FT})}$$